



Docket No.: M4065.0159/P159-B

PATENT)
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Li Li et al.

Confirmation No.: 5524

Application No.: 09/939,651

Art Unit: 1765

Filed: August 28, 2001

Examiner: B. Tran

For: METHOD OF CONTROLLING
STRIATIONS AND CD LOSS IN CONTACT
OXIDE ETCH

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated October 23, 2003 (Paper No. 12), please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.